OCKET NO: 245637US0

## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

TAKASHI TATSUMI ET AL

: ATTN: APPLICATIONS DIVISION

SERIAL NO: 10/716,427

FILED: NOVEMBER 20, 2003

FOR: MESOPOROUS SILICA AND PROCESS FOR PRODUCING THE SAME

## PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313-1450

SIR:

Prior to examination on the merits, please amend the above-identified application as follows:

Amendments to the Specification begins on page 2 of this response.

Amendments to the Claims begins on page 4 of this response.

Remarks begin on page 8 of this response.